# 10/563854

# IAP20 RESILLETTO 06 JAN 2006

### **Application Data Sheet**

## **Application Information**

Regular Application Type::

Subject Matter:: Utility

Suggested Group Art Unit:: N/A

None CD-ROM or CD-R?::

Sequence submission?:: None

No Computer Readable Form (CRF)?::

**GROWTH METHOD FOR NITRIDE** Title::

No

SEMICONDUCTOR EPITAXIAL LAYERS

20506/0203830-US0 Attorney Docket Number::

Request for Early Publication?:: No

No Request for Non-Publication?::

Suggested Drawing Figure:: Fig. 4

Small Entity?:: No Petition included?::

Secrecy Order in Parent Appl.?:: No

#### **Applicant Information**

Inventor Applicant Authority Type::

Primary Citizenship Country:: Republic of Korea

**Full Capacity** Status::

Euijoon Given Name::

Yoon Family Name::

City of Residence:: Seoul

Country of Residence:: Republic of Korea

Street of mailing address:: Rm. 33-219, School of Material Science and

Engineering,

Seoul National University

City of mailing address:: Seoul

Republic of Korea Country of mailing address::

Postal or Zip Code of mailing address:: 151-742

Applicant Authority Type:: Inventor

Primary Citizenship Country:: Republic of Korea

Status:: Full Capacity

Given Name:: Hyunseok

Family Name:: Na

City of Residence:: Seoul

Country of Residence:: Republic of Korea

Street of mailing address:: Rm. 131-107, Research Institute of

Advanced Materials,

Seoul National University

City of mailing address:: Seoul

Country of mailing address:: Republic of Korea

Postal or Zip Code of mailing address:: 151-742

**Correspondence Information** 

Correspondence Customer Number:: 07278

Representative Information

Representative Customer Number:: 07278

#### **Domestic Priority Information**

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	National Stage of	PCT/KR2004/001665	07/07/04

#### **Foreign Priority Information**

Country::	Application number::	Filing Date::	Priority Claimed::
Korea, Republic of	10-2003-0046119	07/08/03	Yes

#### **Assignee Information**

Assignee name:: Seoul National University Industry

Foundation

Street of mailing address:: San 4-2, Bongcheon-dong, Kwanak-gu

City of mailing address:: Seoul

Country of mailing address:: Republic of Korea

Postal or Zip Code of mailing address:: 151-818